

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional) SKI.008C2		Application Number NEW	
				Applicant(s) Shunji Hayashi			
				Filing Date November 14, 2003		Group Art Unit 101 712,100 <i>Unknown</i>	

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>Q</i>	A	5,446,681	08/1995	Gethner et al.			
<i>Q</i>	B	5,586,066	12/1996	White et al.			
<i>Q</i>	C	5,602,938	02/1997	Akiyama et al.			
<i>Q</i>	D	5,726,905	03/1998	Yazici et al.			
<i>Q</i>	E	6,012,019	01/2000	Saby			
<i>Q</i>	F	5,590,036	12/1996	Maeda			
<i>Q</i>	G	5,751,898	05/1998	Kosaka et al.			
<i>Q</i>	H	5,742,522	04/1998	Yazici et al.			
<i>Q</i>	I	6,272,233	08/2001	Takeo			
<i>Q</i>	J	5,835,902	11/1998	Jannarone, Robert			
<i>Q</i>	K	5,544,256	08/1996	Brecher et al.			

FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>		

EXAMINER <i>[Signature]</i>	DATE CONSIDERED <i>8/5/08</i>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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10/712,100

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Group Art Unit
2825



U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A	6,438,440	08/2002	Hayashi			
	B	6,117,601	09/2000	Kanazawa et al.			
	C	2002/0188367	12/2002	Hayashi			
	D	5,392,364	02/1995	Yokoyama et al.			

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
	E	2000-114130	04/21/2000	Japan				
	F	2001-223885 A	08/2001	Japan				
	G	2000-275757 A	10/2000	Japan				
	H	10124766 A	05/1998	Japan				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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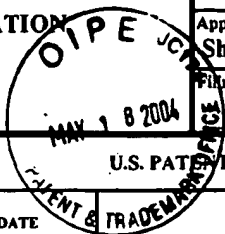
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U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A	6,665,576	12/16/03	Hayashi			
	B	6,603,867	08/05/03	Sugino et al.			

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
	C	JP 09305768 A	11/28/97	Japan				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	D	EP Pub No. 1014191 A2 to Kanazawa et al.

EXAMINER

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